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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

INVENTOR: Kazuhiro FUJIKAWA et al. | DOCKET NO.: 4858

APPLICATION NO.: 10/528,440 | CONFIRM. NO.: 4308

FILING DATE: March 18, 2005 | ART UNIT: 2818

TITLE OF INVENTION: | EXAMINER: T. P. LE  
Method of Fabricating  
Semiconductor DeviceMS AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

September 29, 2006

RESPONSE TO THE OFFICE ACTION OF SEPTEMBER 6, 2006, INCLUDING AN  
ATTACHED COVER SHEET WITH CERTIFICATE OF TELEFAX TRANSMISSION

Dear Sir:

[RESPONSE CONTINUES ON NEXT PAGE]

4858/WFF:he

- 1 -

Please amend the Foreign Priority Claim of this application in accordance with the enclosed "Revised Priority Claim", by **deleting** the foreign priority claim to Japanese patent application 2003-144624 of May 22, 2003. Only the foreign priority of Japanese patent application 2003-122240 of April 25, 2003 is now still being claimed.

No further amendments are being made in this Response.

[RESPONSE CONTINUES ON NEXT PAGE]